



IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:
Tien-I Bao

Confirmation Number: 4415

Serial No.: 10/618,219

Group Art Unit: 1763
Examiner: Goudreau, George A.

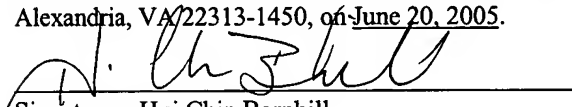
Filed: July 10, 2003

TKHR Docket No. 252011-1390
Top-Team Ref. 0503-7148US

For: METHOD FOR PREVENTING FORMATION OF PHOTORESIST SCUM

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 20, 2005.


Signature - Hui Chin Barnhill

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The non-final Office Action mailed April 5, 2005 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.